

Docket No.: 043890-0449

PATENT**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of : Customer Number: 20277  
Hidenori KAMEI, et al. : Confirmation Number: 4504  
Application No.: 09/680,943 : Group Art Unit: 2823  
Filed: October 10, 2000 : Allowed: September 08, 2005  
Examiner: George R. Fourson III  
For: P-TYPE NITRIDE SEMICONDUCTOR AND METHOD OF  
MANUFACTURING THE SAME

**INFORMATION DISCLOSURE STATEMENT****FAX RECEIVED**

Mail Stop IDS  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

DEC 05 2005

**OFFICE OF PETITIONS**

Dear Sir:

In accordance with the provisions of 37 C.F.R. 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the reference listed on the attached form PTO-1449. It is respectfully requested that the reference be expressly considered during the prosecution of this application, and that the reference be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

**Certification of Facsimile Transmission**  
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Respectfully submitted,  
McDERMOTT WILL & EMERY LLP



Michael E. Fogarty  
Registration No. 36,139

600 13<sup>th</sup> Street, N.W.  
Washington, DC 20005-3096  
Phone: 202.756.8000 MEF:jam  
Facsimile: 202.756.8087  
**Date: December 5, 2005**

**Please recognize our Customer No. 20277  
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